

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Bor-Jen WU**

Serial No.: **NEW**

Filed: **November 18, 2003**

For: **METHOD FOR FORMING AN OPTO-ELECTRONIC DEVICE**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 18, 2003

Sir:

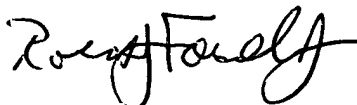
In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2394.

Respectfully submitted,

IPS, Inc.



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Enclosures: PTO-1449; Reference (1).

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No.: 030112	Serial No.: New Appln.
	Applicant: Bor-Jen WU	
	Filing Date: November 18, 2003	Group Art Unit: Not yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					
_____	AE					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____	AF		
_____	AG		
_____	AH		
_____	AI		
_____	AJ		

OTHER DOCUMENTS

_____	AK	L. C. Wang, et al. "Low Temperature-Processed (150-175°C) Ge/Pd-Based Ohmic Contacts ($\rho_c \sim 1 \times 10^{-6} \Omega \text{ cm}^2$) to η -GaAs" - Appl. Phys. Lett., pp. 67 - July 24, 1995
_____	AL	
Examiner		Date Considered